IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No		, 09/943,180
Filing Date	· · · · · · · · · · · · · · · · · · ·	August 29, 2001
Inventor	JAN 1 200 S	August 29, 2001
Assignee		Micron Technology, Inc Unknown
Group Art Unit	PRADEMAR	
Examiner		Unknown
Attorney's Docket No		MI22-1776
		pacitors, and Methods of Forming Capacitor
Dielectric Layers		· ·

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Depos Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpairment of the above fee.

Respectfully submitted,

Mark S. Matkin, P.S.

Reg. No. 32,268

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